Attorney Docket No.: Serial No.: INFORMATION DISCLOSURE CITATION 10/507,321 46884-5317 Page 1 of 1 (Use several sheets if necessary) Applicants: Yoshimaro FUJII et al. Filing Date: June 28, 2005 Group Art Unit: 2812 **PTO Form 1449 U.S. PATENT DOCUMENTS** *Examiner Document Sub Class Filing Date Initial Number Date Name Class FOREIGN PATENT DOCUMENTS Document Sub Translation Number Date Country Class Class YES NO WO 2004/082006 A1 September 23, 2004 PCT **Abstract** /EU/ /Elias Ullah/ (06/19/2007) Date Considered Examiner 06/19/2007 Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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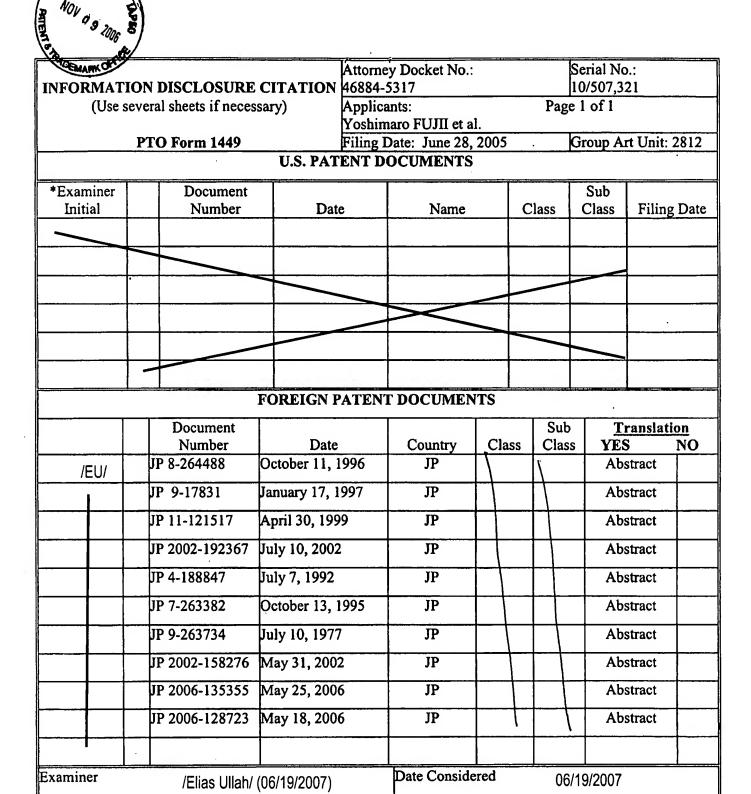
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Attorney Docket No.: Serial No.: INFORMATION DISCLOSURE CITATION 46884-5317 10/507,321 (Use several sheets if necessary) **Applicants** Page 1 of 1 Yoshimaro FUJII et al. Filing Date: September 10, 2004 Group Art Unit: 2812 **PTO Form 1449** U.S. PATENT DOCUMENTS *Examiner Document Sub **Initial** Number Class Date Name Class Filing Date FOREIGN PATENT DOCUMENTS Document Sub Translation Number Date Country Class Class YES NO 2001-326194 November 22, 2001 JP /EU/ Abstract 7EU/ 11-071124 March 16, 1999 JP Abstract /EU/ 04-111800 April 13, 1992 JP Abstract 7EU/ 61-112345 May 30, 1986 JP Abstract Examiner Date Considered /Elias Ullah/ (06/19/2007) 06/19/2007 Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next

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